INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 9, 2026	
IGI Report Number	LG837644682
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUSHION MIXED CUT
Measurements	10.67 X 7.32 X 4.81 MM

GRADING RESULTS

Carat Weight	3.65 CARATS
Color Grade	E
Clarity Grade	VVS 2

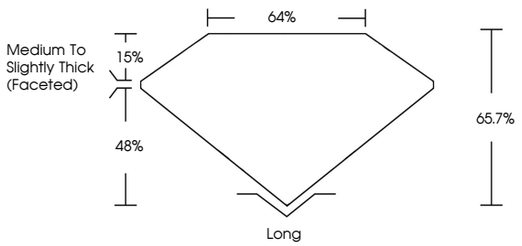
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG837644682

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG837644682
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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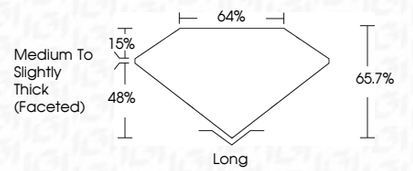
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www.igi.org

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CUSHION MIXED CUT
10.67 X 7.32 X 4.81 MM
Carat Weight 3.65 CARATS
Color Grade E
Clarity Grade VVS 2
Depth 65.7%
Table 64%
Girdle Medium To Slightly Thick (Faceted)
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG837644682
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